



Application No. 09/927,444  
Docket No.: 006217 USA/Consilium/Consilium

2125  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :  
Nicholas A. WARD et al. :  
Serial No. 09/927,444 : Group Art Unit: 2125  
Filed: August 13, 2001 : Examiner: Sean P. Shechtman  
For: Dynamic Control Of Wafer Processing Paths In  
Semiconductor Manufacturing Processes

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Technology Center 2100

AMENDMENT

Honorable Commissioner for Patents  
Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action mailed January 20, 2004, having a response due by July 20, 2004. The following remarks are respectfully submitted.

**Amendments to the Specification** begins on Page 2 of this paper.

**Listing of Claims** begins on Page 3 of this paper.

**Remarks/Arguments** begin on Page 7 of this paper.